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JUN 23 2004

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: Simpson, *et al.*

Docket No.: 02 P 00543 US

Serial No.: 10/067,587

Art Unit: 1765

Filed: February 4, 2002

Examiner: Vinh, Lan

Title: Polyelectrolyte Dispensing Polishing Pad, Production Thereof and Method of
Polishing a Substrate

OFFICIAL

Mail Stop: Amendment
Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450FEE Recorded
onlyAMENDMENT

Dear Sir:

The following amendments and remarks are presented in response to the Examiner's

Office Action mailed March 31, 2003. Please amend the above-referenced application as
follows.

07/09/2004 WHITCHEL 00000002 501065 10067587

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Amendment